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RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 2818
PATENT
Attorney Docket No. 04329.3238

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Gaku MINAMIHABA et al.) Group Art Unit: 2818
Application No. 10/771,060) Examiner: Goodwin, David J.
Filed: February 4, 2004) Confirmation No.: 2231
For: POLISHING PAD AND METHOD OF)
MANUFACTURING)
SEMICONDUCTOR DEVICES)

Mailstop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION AFTER FINAL

In reply to the Final Office Action mailed August 1, 2007, the period for response to which extending through November 1, 2007, Applicants request the Examiner's reconsideration in view of the remarks that follow: